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CONFIRMATION NO. 2851

| SERIAL NUMBER | FILING or 371(c) DATE RULE | CLASS | GROUP ART UNIT | ATTORNEY DOCKET NO. |
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| 10/516,414 | | 438 | 1795 | SON-2774 |

APPLICANTS

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**** CONTINUING DATA *******

This application is a 371 of PCT/JP03/07377 06/10/2003

**** FOREIGN APPLICATIONS *******

JAPAN 2002-186232 06/26/2002

**** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ****

07/03/2006

| Foreign Priority claimed | <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | STATE OR COUNTRY | SHEETS DRAWINGS | TOTAL CLAIMS | INDEPENDENT CLAIMS |
|--------------------------------|---|--|-----------------|--------------|--------------------|
| 35 USC 119(a-d) conditions met | <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | | | | |
| Verified and Acknowledged | /STEWART A FRASER/ Examiner's Signature | <input type="checkbox"/> Met after Allowance Initials | JAPAN | 14 | 20 |
| | | | | | 7 |

ADDRESS

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TITLE

Mask, ,method of producing the same, and method of producing semiconductor device

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|------------------------------------|---|---|
| FILING FEE RECEIVED 1302 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit |
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